

#29
Condit J/K
7/12-11-98

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hidehiko KIRA et al.

Serial No. 08/897,953

Filed: July 24, 1997

For: METHOD AND APPARATUS FOR FABRICATING SEMICONDUCTOR DEVICE



Group Art Unit: 2814

Examiner: David E. GRAYBILL

Spruill
1-20-99

DPA 11-6-98
DO NOT ROUTER
12-28-98

RESPONSE UNDER 37 C.F.R. §1.116
- EXPEDITED RESPONSE -
GROUP ART UNIT 2814

BOX AF

Assistant Commissioner of Patents
Washington, D. C. 20231

RECEIVED
TECHNOLOGY CENTER 2800
OCT 9 PM 2:14
December 7, 1998

Sir:

In response to the Office Action dated July 6, 1998, please amend this application as follows:

IN THE DRAWINGS:

The applicants respectfully submit herewith a Request for Approval of Drawings. Corrections along with proposed drawing corrections to Figure 3, marked in red ink.